ABSTRACT OF THE DISCLOSURE

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A solar cell production method includes the steps of: forming a first electrode layer on a substrate, sequentially forming a p-layer, an i-layer and an n-layer of amorphous silicon on the first electrode layer, and forming a second electrode layer on the n-layer, wherein the i-layer is formed by a plasma CVD method employing plasma discharge caused by application of a pulse-modulated high frequency voltage having a pulse ON time of not longer than $50 \, \mu$ sec and a duty ratio of not higher than 50% to improve a photo-electric conversion efficiency of the solar cell.